



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

**Confirmation No. 7449**

Kazuhiro OTSU et al.

: Docket No. 2002\_0208A

Serial No. 10/067,370

: Group Art Unit 2818

Filed February 7, 2002

: Examiner Thao P. Le

SEPARATING MACHINE FOR THINNED  
SEMICONDUCTOR SUBSTRATE AND  
SEPARATION METHOD

THE COMMISSIONER IS AUTHORIZED  
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**SUBMISSION OF FORMAL DRAWINGS**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In accordance with Patent Office practice, submitted herewith are formal drawings for  
Figs. 1-5 (2 sheets, A4 Paper).

Respectfully submitted,

Kazuhiro OTSU et al.

By: Michael S. Huppert  
Michael S. Huppert  
Registration No. 40,268  
Attorney for Applicants

MSH/kjf

Washington, D.C. 20006-1021  
Telephone (202) 721-8200  
Facsimile (202) 721-8250  
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Fig.1

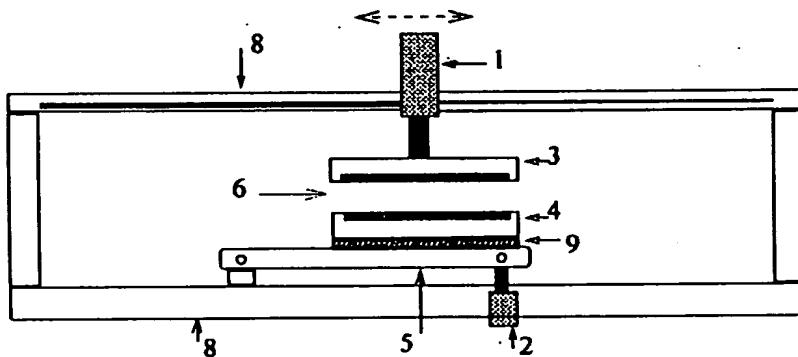


Fig.2

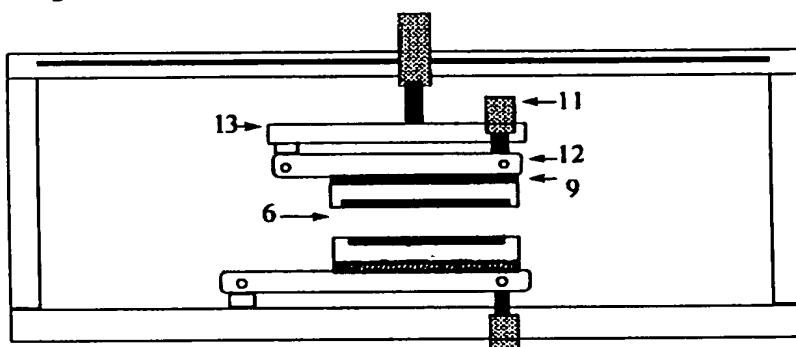


Fig.3

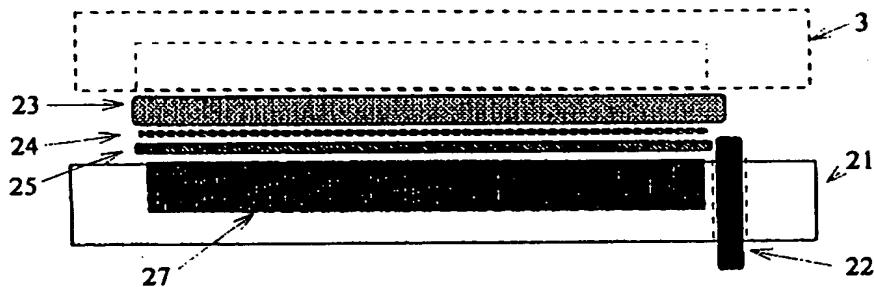


Fig.4

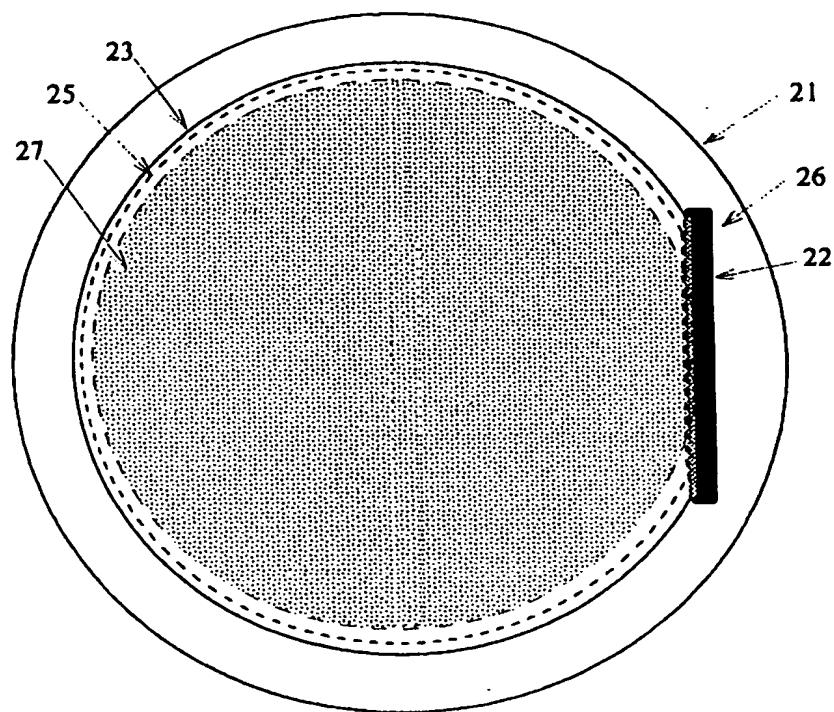


Fig.5

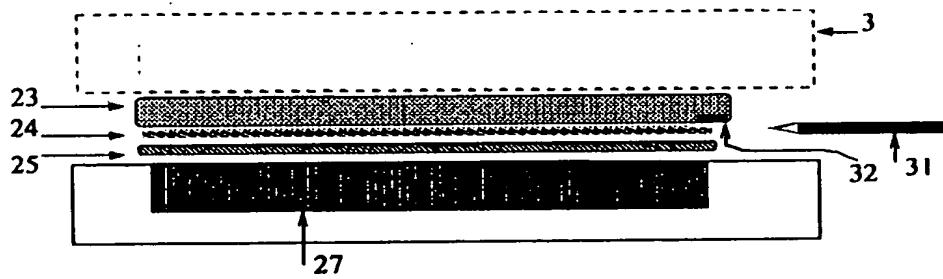


Fig.6

